

IN 09/940917

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|             |                                       |                 |               |
|-------------|---------------------------------------|-----------------|---------------|
| Applicant:  | Gurtej S. Sandhu et al.               | Examiner:       | Jeff Vockrodt |
| Serial No.: | 09/940917                             | Group Art Unit: | 2822          |
| Filed:      | August 28, 2001                       | Docket:         | 303.676US2    |
| Title:      | CHEMICAL VAPOR DEPOSITION OF TITANIUM |                 |               |

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(c)(2), please charge Deposit Account No. 19-0743 in the amount of of \$180.00 as set forth in 37 C.F.R. §1.17(p).

The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

GURTEJ S. SANDHU ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
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Minneapolis, MN 55402  
(612) 373-6944

05/18/2004 SDENB0B1 00000112 190743 09940917  
01 FC:1806 180.00 DA

Date

5-11-04

By

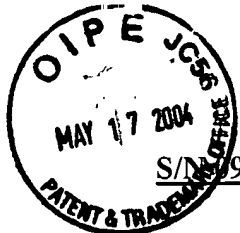
David C. Peterson  
Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 12th day of May, 2004.

Name

Amy Moriarty

Signature



S/N 09/940917

PATENT

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**COMMUNICATION CONCERNING RELATED APPLICATION(S)**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

| <u>Serial/Patent No.</u> | <u>Filing Date</u>   | <u>Attorney Docket</u> | <u>Title</u>                               |
|--------------------------|----------------------|------------------------|--|
| 09/030705<br>6143362     | February<br>25, 1998 | 303.289US1             | CHEMICAL VAPOR DEPOSITION OF<br>TITANIUM   |
| 09/389562<br>6433434     | September<br>3, 1999 | 303.289US2             | APPARATUS HAVING A TITANIUM<br>ALLOY LAYER |
| 09/489187<br>6284316     | January 20,<br>2000  | 303.676US1             | CHEMICAL VAPOR DEPOSITION OF<br>TITANIUM   |
| 09/941123                | August 28,<br>2001   | 303.676US3             | CHEMICAL VAPOR DEPOSITION OF<br>TITANIUM   |
| 09/940980                | August 28,<br>2001   | 303.676US4             | CHEMICAL VAPOR DEPOSITION OF<br>TITANIUM   |
| 09/941125                | August 28,<br>2001   | 303.676US5             | CHEMICAL VAPOR DEPOSITION OF<br>TITANIUM   |

COMMUNICATION CONCERNING RELATED APPLICATIONS

Serial Number: 09/940917

Filing Date: August 28, 2001

Title: CHEMICAL VAPOR DEPOSITION OF TITANIUM

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Dkt: 303.676US2



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By Applicants' Representatives,

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Date

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By

David C. Peterson

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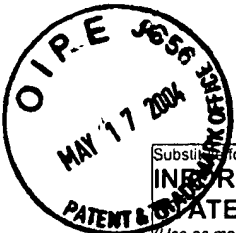
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Name

Amy Moriarty

Signature

[Handwritten signature]



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Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

|                      |                 |
|----------------------|-----------------|
| Application Number   | 09/940917       |
| Filing Date          | August 28, 2001 |
| First Named Inventor | Sandhu, Gurtej  |
| Group Art Unit       | 2822            |
| Examiner Name        | Vockrodt, Jeff  |

Sheet 1 of 1

Attorney Docket No: 303.676US2

**US PATENT DOCUMENTS**

| Examiner Initial * | USP Document Number | Publication Date | Name of Patentee or Applicant of cited Document | Class | Subclass | Filing Date If Appropriate |
|--------------------|---------------------|------------------|---|-------|----------|----------------------------|
|                    | US-4,782,380        | 11/01/1988       | Shankar, K , et al.                             | 257   | 751      | 01/22/1987                 |
|                    | US-5,401,674        | 03/28/1995       | Anjum, , et al.                                 | 437   | 190      | 06/10/1994                 |
|                    | US-6,433,434        | 08/13/2002       | Sandhu, G. S., et al.                           | 257   | 764      | 09/03/1999                 |

**FOREIGN PATENT DOCUMENTS**

| Examiner Initials* | Foreign Document No | Publication Date | Name of Patentee or Applicant of cited Document | Class | Subclass | T <sup>2</sup> |
|--------------------|---------------------|------------------|---|-------|----------|----------------|
|                    | JP-56995            | 01/14/1993       | Kazuhisa, Koyama                                |       |          |                |

EXAMINER

DATE CONSIDERED

Substitute Disclosure Statement Form (PTO-1449)

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional) 2 Applicant is to place a check mark here if English language Translation is attached